

IN THE SPECIFICATION:

(1) Kindly replace paragraph [0025] with the following rewritten paragraph:

--Turning briefly to FIGURE 2, illustrated is one embodiment of a ~~multix-axis~~ multi-axis MEMS device 200 (MEMS device 200) that is free to be driven ~~inbuilt~~ and constructed according to the principles of the present invention. The MEMS device 200 has a mirror 210. The MEMS device 200 also has two pairs of drive electrodes. A first drive electrode pair 220 has a first drive electrode 220a and a second drive electrode 220b. A second drive electrode pair 225 has a first drive electrode 225a and a second drive electrode 225b.--